



MS AF  
**RESPONSE UNDER 37 CFR 1.116**  
**EXPEDITED PROCEDURE**  
**EXAMINING GROUP 2814**

PATENT  
0763-0138P

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

|            |   |            |               |
|------------|---|------------|---------------|
| Applicant: | YANG, Hae C.  | Conf. No.: | 1780          |
| Appl. No.: | 09/452,809  | Group:     | 2814          |
| Filed:     | December 2, 1999  | Examiner:  | Dana Farahani |
| For:       | ESD PROTECTION CIRCUIT AND METHOD FOR<br>FABRICATING THE SAME |            |               |

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MS AF**

Honorable Commissioner of Patents  
Washington, D.C. 20231

November 10, 2003  
(Monday)

Sir:

In response to the Examiner's Office Action dated August 8, 2003 the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

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